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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/736,677	12/17/2003	Yun Bok Lee	8733.977.00-US	4107	
30827	7590 06/15/2005		EXAM	EXAMINER	
MCKENNA LONG & ALDRIDGE LLP 1900 K STREET, NW			FERNANDEZ, KALIMAH		
	DN, DC 20006		ART UNIT	PAPER NUMBER	
	,		2881		
			DATE MAILED: 06/15/2003	DATE MAILED: 06/15/2005	

Please find below and/or attached an Office communication concerning this application or proceeding.

	Application No.	Applicant(s)			
	10/736,677	LEE ET AL.			
Office Action Summary	Examiner	Art Unit			
	Kalimah Fernandez	2881			
The MAILING DATE of this communication Period for Reply	appears on the cover sheet with	h the correspondence address			
A SHORTENED STATUTORY PERIOD FOR RE THE MAILING DATE OF THIS COMMUNICATIO - Extensions of time may be available under the provisions of 37 CFI after SIX (6) MONTHS from the mailing date of this communication - If the period for reply specified above is less than thirty (30) days, a - If NO period for reply is specified above, the maximum statutory pe - Failure to reply within the set or extended period for reply will, by st Any reply received by the Office later than three months after the m earned patent term adjustment. See 37 CFR 1.704(b).	ON. R 1.136(a). In no event, however, may a repl. I reply within the statutory minimum of thirty riod will apply and will expire SIX (6) MONT atute, cause the application to become ABA	oly be timely filed (30) days will be considered timely. HS from the mailing date of this communication NDONED (35 U.S.C. § 133).	on.		
Status					
1) Responsive to communication(s) filed on _					
· · · · · · · · · · · · · · · · · · ·	This action is non-final.				
3) Since this application is in condition for allo	wance except for formal matte	rs, prosecution as to the merits i	is		
closed in accordance with the practice und	er Ex parte Quayle, 1935 C.D.	11, 453 O.G. 213.			
Disposition of Claims					
4) Claim(s) 1-8 and 11-19 is/are pending in th	e application.				
4a) Of the above claim(s) is/are with	drawn from consideration.				
5) Claim(s) is/are allowed.		•			
6)⊠ Claim(s) <u>1-8 and 11-19</u> is/are rejected.					
7) Claim(s) is/are objected to.					
8) Claim(s) are subject to restriction ar	nd/or election requirement.	·	•		
Application Papers					
9)☐ The specification is objected to by the Exan	niner.				
10) The drawing(s) filed on is/are: a) accepted or b) objected to by the Examiner.					
Applicant may not request that any objection to	the drawing(s) be held in abeyand	e. See 37 CFR 1.85(a).			
Replacement drawing sheet(s) including the co	rrection is required if the drawing(s) is objected to. See 37 CFR 1.121	(d).		
11)☐ The oath or declaration is objected to by the	e Examiner. Note the attached	Office Action or form PTO-152.			
Priority under 35 U.S.C. § 119			•		
12) ☐ Acknowledgment is made of a claim for fore a) ☐ All b) ☐ Some * c) ☐ None of: 1. ☐ Certified copies of the priority documents of the priority documents.	nents have been received.	,			
2. Certified copies of the priority docum	•	·			
 Copies of the certified copies of the papplication from the International Bull 	•	eceived in this National Stage			
* See the attached detailed Office action for a	, , , ,	eceived.	·		
Attachment(s)					
1) Notice of References Cited (PTO-892)	· —	ımmary (PTO-413) /Mail Date			
 2) Notice of Draftsperson's Patent Drawing Review (PTO-948) 3) Information Disclosure Statement(s) (PTO-1449 or PTO/SE 	′	ormal Patent Application (PTO-152)			
Paper No(s)/Mail Date	6) Other:		•		

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DETAILED ACTION

Claim Rejections - 35 USC § 102

The following is a quotation of the appropriate paragraphs of 35
 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.

- 2. Claims 1-6,8 and 11-13 are rejected under 35 U.S.C. 102(b) as being anticipated by US Pat No 6,236,163 issued to Maishev et al.
- 3. Maishev et al disclose an ion beam irradiation device (see col.1, lines 14-18).
- 4. Maishev et al disclose a holder (see for example col.8, lines 27-34; col.11, lines 58-59).
- 5. Maishev et al disclose an ion beam path (see fig. 10).
- 6. Maishev et al disclose an ion beam source (702) that is a predetermined distance from the substrate (ob3) and inclined to be substantially parallel with the substrate (ob3) and that irradiates the substrate (ob3) (see fig. 10).

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7. Maishev et al disclose an ion beam is discharged from the ion source (702) with an incidence angle with respect to the ion beam source (702) that is greater than about 0^0 (see fig. 10; col.12, lines 8-41).

- 8. As per claims 2-6, Maishev et al disclose an ionizer, discharger, and an accelerator (col.3, lines 10-16), wherein his invention improves the conventional art depicted in fig. 1-3 (see also col.10, lines 29-40).
- 9. As per claim 8, Maishev et al disclose the use of Ar (see col.3, lines 10-11).
- 10. As per claims 11-13, Maishev et al disclose the recited angle range (see col.7, lines 34-37).

Claim Rejections - 35 USC § 103

11. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

12. Claims 7 and 14-19 are rejected under 35 U.S.C. 103(a) as being unpatentable over Maishev et al and in view of US Pat No 5,770,826 issued to Chaudhari et al.

13. Maishev et al teach the claimed invention except for an alignment layer.

- 14. However, Chaudhari et al teach the desirability of an alignment layer (see for example col.2, lines 1-19).
- 15. It would have been obvious to an ordinary artisan at the time of the invention to combine Maishev et al and Chaudhari et al, because Chaudhari et al teach improved alignment in liquid crystal display.
- 16. As per claim 15, Maishev et al disclose an ionizer, discharger, and an accelerator (col.3, lines 10-16), wherein his invention improves the conventional art depicted in fig. 1-3 (see also col.10, lines 29-40).
- 17. As per claim 16, Maishev et al disclose the use of Ar (see col.3, lines 10-11).
- 18. As per claims 17-19, Maishev et al disclose the recited angle range (see col.7, lines 34-37).

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Kalimah Fernandez whose telephone number is 571-272-2470. The examiner can normally be reached on Mon-Tues 6:30-3:30; Wed-Thurs 8-5 and Fri.9am-6 pm.

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If attempts to reach the examiner by telephone are unsuccessful, the

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examiner's supervisor, John R. Lee can be reached on 571-272-2477. The

fax phone number for the organization where this application or proceeding

is assigned is 703-872-9306.

Information regarding the status of an application may be obtained

from the Patent Application Information Retrieval (PAIR) system. Status

information for published applications may be obtained from either Private

PAIR or Public PAIR. Status information for unpublished applications is

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access to the Private PAIR system, contact the Electronic Business Center

(EBC) at 866-217-9197 (toll-free).

KF

SUPERVISORY PATENT EXAMINER